

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Akira SUZUKI et al.

Application No.: 10/784,888

Group Art Unit: 2812

Filed: February 24, 2004

Examiner: Not Yet Assigned

For: MANUFACTURING METHOD OF
SEMICONDUCTOR DEVICE

CLAIM FOR PRIORITY AND SUBMISSION OF DOCUMENT

Commissioner for Patents
2011 South Clark Place
Room 1B03, Crystal Plaza 2
Arlington, Virginia, 22202

Sir:

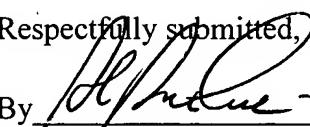
Applicants hereby claim priority under 35 U.S.C. 119 based on the following prior foreign applications filed in the following foreign country on the date indicated:

Country	Application No.	Date
Japan	2003-046755	February 25, 2003
Japan	2004-026534	February 3, 2004

In support of this claim, certified copies of the original foreign applications are filed herewith.

Dated: July 16, 2004

Respectfully submitted,

By 

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